

# 5 PrelAmend  
D. D. 100  
9-18-01

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Priority Application Serial No. .... 09/837,645  
Priority Filing Date .... April 17, 2001  
Inventor .... Sandhu et al.  
Assignee .... Micron Technology, Inc.  
Priority Group Art Unit .... 2813  
Priority Examiner .... Schillinger, L.  
Attorney's Docket No. .... MI22-1780  
Title: Methods of Forming a Thin Film Transistor

PRELIMINARY AMENDMENT

To: ~~BOX PATENT APPLICATION~~  
Assistant Commissioner for Patents  
Washington, D.C. 20231

From: Jennifer J. Taylor, Ph.D. (Tel. 509-624-4276; Fax 509-838-3424)  
Wells, St. John, Roberts, Gregory & Matkin P.S.  
601 W. First Avenue, Suite 1300  
Spokane, WA 99201-3828

AMENDMENTS

In the Specification

At p. 1, before the "Technical Field" Section, insert

--RELATED PATENT DATA

This patent is a divisional application of U.S. Patent Application Serial No. 09/837,645 which was filed on April 17, 2001, which is a continuation of U.S. Patent No. 6,238,957, issued on May 29, 2001, which is a continuation of U.S. Patent No. 6,001,675, issued on December 14, 1999, which is a continuation of U.S. Patent No. 5,665,611, which was issued on September 9, 1997.--

09/02/01 10:00:00

B1